



AP/2876  
Jhw/A

**PATENT**  
Atty. File No: 83975

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicant: Satoshi Kitagawa

Serial No.: 09/696,117

Filed: October 25, 2000

For: **MARKING METHOD FOR SEMICONDUCTOR  
WAFER**

Examiner: Lisa M. Caputo

) Confirmation No. 4414

) Group Art Unit: 2876

) *I hereby certify that this correspondence is  
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) Mail Stop AMENDMENT, Commissioner for  
) Patents, P.O. Box 1450, Alexandria, VA,  
) 22313-1450, on November 8, 2004*

)   
) Gerald T. Shekleton, Reg. No 27,466

**AMENDMENT**

Mail Stop AMENDMENT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

*Entered  
12/7/04  
ahw*

Dear Sir:

The Office Action of August 12, 2004 has been carefully reviewed and the following amendments and remarks are made in response thereto.

Ok to enter the 11/24/04